



AF/2822  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MANABU TOMITA ET AL.

Serial No. 09/387,477 (TIJ-26105)

Filed September 1, 1999

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Art Unit 2822

Examiner M. Guerrero

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

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4-19-05

Jay M. Cantor, Reg. No. 19.906

Sir:

**AMENDMENT UNDER 37 C.F.R. 1.116**

In response to the Office action dated March 11, 2005, please amend the above-identified application as follows: